

<b>Notice of References Cited</b>	Application/Control No. 10/614,848	Applicant(s)/Patent Under Reexamination HEBIGUCHI, HIROYUKI	
	Examiner Wen-Ying P. Chen	Art Unit 2871	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2001/0013912	08-2001	YAMAZAKI et al.	349/113
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	C	US-			
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